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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Keigo MIZUTANI et al.

Group Art Unit: 1753

Application No.: 10/067,212

Examiner: K. Olsen

Filed: February 7, 2002

Docket No.: 111920

For: IMPROVED STRUCTURE OF GAS SENSOR ELEMENT DESIGNED TO MINIMIZE
ERROR OR SENSOR OUTPUT

SUPPLEMENTAL AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In further reply to the April 7, 2004 Office Action and the personal interview
conducted on July 27, 2004, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.